

Message Text

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FM SECSTATE WASHDC
TO AMEMBASSY TOKYO PRIORITY

C O N F I D E N T I A L STATE 167959

LIMDIS FOR ECOMIN BUTTON FROM DAS HEGINBOTHAM

E.O. 11652: GDS

TAGS: ETRD, EIND, JA, US

SUBJECT: SEMICONDUCTOR INDUSTRY

1. AS EMBASSY AWARE, U.S. SEMICONDUCTOR INDUSTRY ASSOCIATION (SIA) HAS BUDGETED \$250,000 FOR ACTIVITIES AIMED AT INCREASING MARKET ACCESS OF AMERICAN SEMICONDUCTOR FIRMS EXPORTING TO JAPAN. SIA HAS HIRED JOHN VAN SAUN AS PROJECT MANAGER FOR THIS EFFORT. IT IS OUR UNDERSTANDING THAT SIA OFFICIALS ENVISAGED A MAJOR PUSH THROUGH THE TRADE STUDY GROUP (TSG). VAN SAUN HAS CALLED ON SENIOR OFFICIALS IN STATE, COMMERCE, AND STR REGARDING THIS PROJECT AND PLANS TO VISIT TOKYO JULY 1-14 TO MEET WITH EMBASSY AND GOJ OFFICIALS, AS WELL AS WITH BALLOUN AND OTHERS IN THE ACCJ.

2. WE ARE CONCERNED THAT, IN ADDITION TO PURSUING IMPROVED MARKET ACCESS THROUGH THE TSG, VAN SAUN HAS
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CONTACTED MEMBERS OF CONGRESS AND THE INTERNATIONAL TRADE COMMISSION TO SEEK SUPPORT FOR VARIOUS INITIATIVES UNDER U.S. STATUTES CONCERNING DUMPING, EXPORT SUBSIDIZATION, AND UNFAIR TRADE PRACTICES. WE BELIEVE THAT TSG ROUTE IS THE APPROPRIATE ONE FOR THE U.S.

SEMICONDUCTOR INDUSTRY TO FOLLOW.

3. WE WOULD APPRECIATE EMBASSY ASSESSMENT OF SIA
APPROACHES IN JAPAN, PARTICULARLY AS TO WHETHER
VAN SAUN INFORMS GOJ CONTACTS OF HIS EFFORTS WITH THE

ITC, STR, AND CONGRESS. VANCE

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Message Attributes

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